DO NOT ENTER: /HS/

01/14/2010

## **PATENT APPLICATION**

## **RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 3727**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi IGARASHI et al.

Group Art Unit: 3727

Application No.: 10/611,918

Examiner:

H. SHAKERI

Filed: July 3, 2003

Docket No.: 108833.01

For:

LENS MACHINING APPARATUS, LENS MACHINING METHOD, AND LENS

MEASUREMENT METHOD

## **AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. §1.116**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the November 18, 2009 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.